

***FARJAMI & FARJAMI LLP***
AN INTELLECTUAL PROPERTY LAW FIRM

www.farjami.com

**RECEIVED
CENTRAL FAX CENTER****MAY 10 2004
OFFICIAL**

26522 La Alameda Avenue, Suite 360
Mission Viejo, California 92691
tel: (949) 282-1000
fax: (949) 282-1002

FACSIMILE TRANSMISSION COVER SHEET**Date:** May 10, 2004**To:** United States Patent and Trademark Office
Examiner Luan C. Thai, Art Unit 2827**Fax:** (703) 872-9306**Re:** **Application Serial No.: 10/618,273**
Filing Date: 7/11/2003; Inventor(s): Jeon, et al.
Attorney Docket No.: 0180142**From:** Farjami & Farjami LLP**Number of pages including the cover sheet:** 6**Message:**

Enclosed please find the Amendment and Response to the Office Action dated April 20, 2004.

Thank you.

The documents accompanying this facsimile contain **PRIVILEGED AND CONFIDENTIAL** information intended only for use of the individual or entity named above. If you are not the intended recipient, disclosure, copying, distribution or use of the contents of this facsimile information is prohibited. If you have received this facsimile in error, please immediately notify us by telephone and return the original facsimile to us at the above address via U.S. Postal Service. We will reimburse you for all expenses incurred.

Attorney Docket No.: 0180142

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
CENTRAL FAX CENTER

MAY 10 2004

OFFICIAL

In re Application of: Jeon, et al.

Serial No.: 10/618,273

Filed: July 11, 2003

For: Method for Forming a Field Effect
Transistor Having a High-K Gate
Dielectric and Related Structure

Art Unit: 2827

Examiner: THAI, LUAN C.

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the Office Action dated April 20, 2004 in the above-referenced patent application. Please enter and consider the following amendments and remarks.